Search Notes		

Application/Control No.	Applicant(s)/Patent under Reexamination
10/618,840	RIPLEY ET AL.
Examiner	Art Unit
Joon H. Hwang	2166

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palm inventor searched see search history printout(s)	3/1/2006	JH
consulted Jean M. Corrielus consulted Alford Kindred consulted Shahid Alam	3/1/2006	JH
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